



Patent Attorney  
Docket No. 81329A

2877  
3

TRANSMITTAL LETTER

Inventor: Joseph J. Danko

Serial No: 09/579,593

Filing Date: 5-26-00

Notice of Allowance:

For: METHOD AND APPARATUS FOR INSPECTING A PATTERNED SEMICONDUCTOR WAFER

Group Art Unit: 2877

Examiner: Unknown

Batch:

Assistant Commissioner for Patents  
Washington, D. C. 20231

Dear Sir:

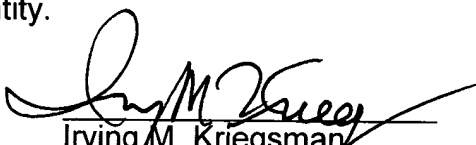
Transmitted herewith for the above-identified patent application are the following:

An Information Disclosure Statement  
Form PTO-FB-A820 (1 sheet)  
Copies of 8 documents  
A return postcard

The item(s) checked below are appropriate:

1. ☐ Applicant(s) hereby petition(s) for a ( ) month extension of time to respond to  
an dated .
2. ☒ Please charge any fees or costs not accounted for to Deposit Account No. 11-  
1755.
3. ☐ Applicant is a small entity.

Date: May 30, 2001

  
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